

In re the Application of: MATSUZAWA, Minoru, et al.

Group Art Unit: 1715

Serial No.: 10/516,949

Examiner: JOLLEY, Kirsten

Filed: December 16, 2004

P.T.O. Confirmation No.: 4976

FOR: SUBSTRATE TREATMENT APPARATUS AND SUBSTRATE TREATMENT

METHOD

RESPONSE UNDER 37 CFR §1.116 - EXPEDITED RESPONSE -**GROUP ART UNIT 1715**

MAILSTOP AF

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

October 15, 2010

Sir:

In response to the Office Action dated July 20, 2010, the following remarks are respectfully submitted:

Remarks/Arguments begin on page 2 of this paper.